



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al. Docket No. : CIL-10972
Serial No. : 10/086,614 Art Unit : 1762
Filed : March 1, 2002 Examiner : B. Pianalto
For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS

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Dear Sir:

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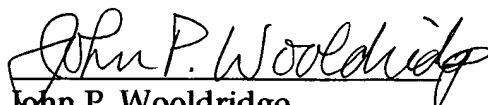
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If you have any questions, please contact the undersigned at 808-270-1011.

Respectfully submitted,


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Dated: April 9, 2004